

<b>Notice of References Cited</b>	Application/Control No. 10/722,597	Applicant(s)/Patent Under Reexamination SUZUKI ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

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*	B	US-2002/0039280	04-2002	O'Connor et al.	361/690
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	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, Fourth Edition, Page 543.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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